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Rih Data Sheet

CONFIRMATION NO. 2926

Bib Data Sneet					1		
SERIAL NUMBER 10/088,306	00/10/2002	CLASS GROU		IID ADI IINII I		ATTORNEY OCKET NO. Q60716	
	RULE				Q00710		
Hiromoto Ohno, Kanagawa, JAPAN; Toshio Ohi, Kanagawa, JAPAN; Shuji Yoshida, Kanagawa, JAPAN; Manabu Ohhira, Kanagawa, JAPAN; Koutarou Tanaka, Kanagawa, JAPAN; *** CONTINUING DATA **********************************							
Foreign Priority claimed 35 USC 119 (a-d) conditi met Verified and Acknowledged	Allowance	state or country JAPAN	SHEETS DRAWIN 1	G CLA	TAL IMS 6	INDEPENDENT CLAIMS 4	
ADDRESS 23373							
TITLE Cleaning gas for semiconductor production equipment							
				☐ All Fees			
	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:			1.16 Fees (Filing)			
FILING FEE F				1.17 Fees (Processing Ext. of time)			
1262 N				☐ 1.18 Fees (Issue)			
				Other			
1				Credit			